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Patent & TRADEMARK OFFICE
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Date of Signature and Deposit: January 14, 2004

Adam J. Frazee
Attorney of Record

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Mark A. Lucak
Serial No.: 09/843,563
Filed: 04/26/01
Examiner: Coleman, William D.
Group Art Unit: 2823
Docket No.: 00AB179
Title: *Method for Fabricating a Microelectromechanical System (MEMS) Device Using a Pre-Patterned Substrate*

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA, 22313-1450

Dear Sir:

In response to the Final Office Action dated October 14, 2003, please amend the above-identified patent application as follows: